

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/771,294	IZAWA ET AL.	
Examiner	Art Unit	
LOIS ZHENG	1793	

	SEARCHED				
Class	Subclass	Date	Examiner		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
Inventorship search	5/6/2010	LLZ
Updated EAST search	5/6/2010	LLZ